

MAR 19 2006

M. ROBERT KESTENBAUM, LLC  
PATENT AND TRADEMARK MATTERS

## FACSIMILE TRANSMITTAL SHEET

TO:	FROM:
Examiner Trinh, Art Unit 3729	M. Robert Kestenbaum
COMPANY:	DATE:
Commissioner for Patents	March 19, 2006
FAX NUMBER:	TOTAL NO. OF PAGES INCLUDING COVER:
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PHONE NUMBER:	SENDER'S REFERENCE NUMBER:
(571) 272 4569	(H) 02ID0374USP
RE:	YOUR REFERENCE NUMBER:
Request for Examiner's Amendment	10/613,870

## NOTES/COMMENTS:

Dear Examiner Trinh:

I am faxing this request for you to complete an Examiner's Amendment to the specification to correct clerical errors in the specification. These changes do not add new matter, but rather, merely conform the description to the specifications set forth in the priority document. Thank you in advance for completing an Examiner's Amendment to correct these errors, and for using these specifications in your continued examination of this application.

Thank you for considering this submission.

Sincerely,

M. Robert Kestenbaum  
Reg. No. 20,430

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MAR 19 2006

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re: US Patent Application 10/613,870

Applicant Heiland  
Art Unit 3729  
Examiner Minh Trinh  
Examiner's Phone (571) 272-4569  
Attorney Docket (H)02ID0374USP

Mail Stop Amendment  
PO Box 1450  
Commissioner for Patents  
Alexandria, Va. 22313-1450

## Request for Examiner's Amendment

Dear Examiner Trinh:

This is submitted in further response to the Office Action mailed 11/01/2005. In reviewing the specification, we found further typographical errors in the specification, which we request you change by Examiner's Amendment. These errors were in paragraphs 0023, 0025, and 0039. The changes we are requesting you make do not add new matter, but merely conform the description to the specifications set forth in the priority document. Thank you in advance for completing an Examiner's Amendment to make these corrections to the specification.

In the specification:

[0023] In an embodiment, the electrode pairs are arranged at a distance from one another in such a way that the wafer can be gripped at the edge. In this way, the advantages of the compact structure of the electrode pairs are optimally utilized. The edge-side gripping allows heating in sensitive regions of the wafer to be reduced still further. For lifting purposes, according to a further embodiment the gripper has three electrode pairs that are arranged on a circular path, ideally at 120 ~~angles~~ degrees around

Heiland (H)02ID0374USP; US Patent Application 10/613,870  
Amendment responding to Office Action mailed 11/01/2005  
Submitted by fax on 01/30/2006

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